

DPI - ON AXIS DIAMOND TURNING OF FULL 8" MASTERS

Marc Wielandts - CEO

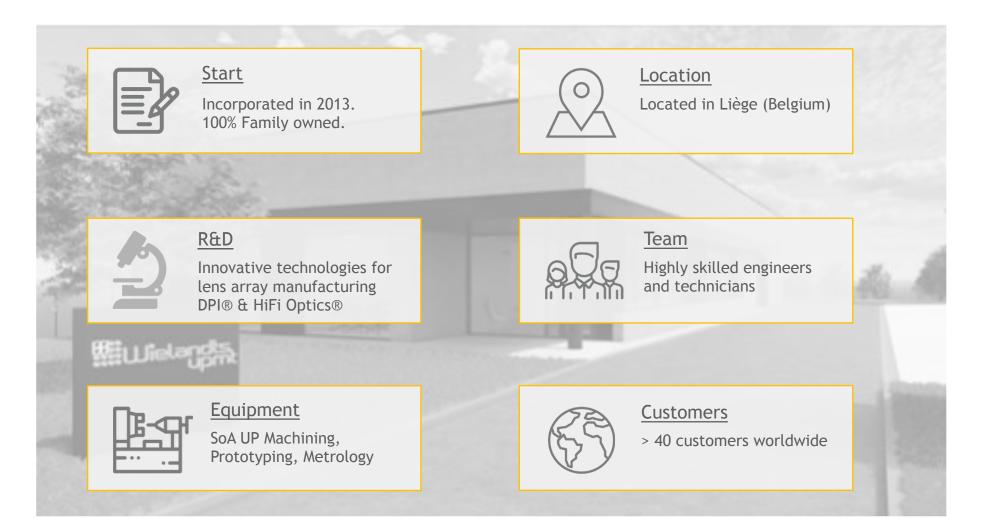
EPIC Meeting on Advanced Microoptics at Nanoscribe - May 2022

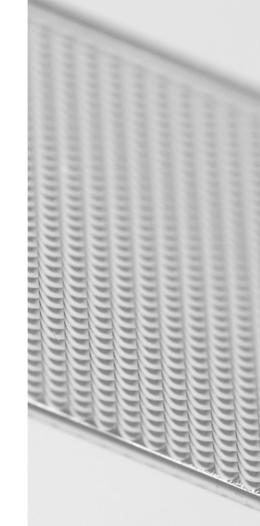






COMPANY INTRODUCTION





Proprietary and Confidential !



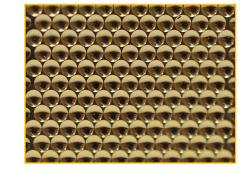


ULTRA PRECISION MANUFACTURING SERVICES

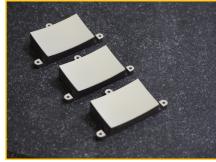
DPI® Lens array masters / inserts

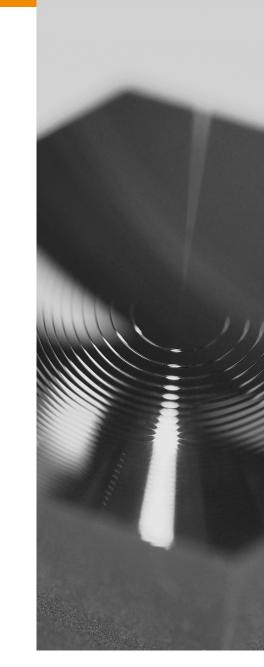
HiFi Optics® Full plastic optics prototyping

SPDT Services









Proprietary and Confidential !



MARKET SEGMENTS AND REQUIREMENTS FOR MASTERS

Market segments:

- MLA sensors for mobile applications, LiDAR, diffusers, ...
- Automotive MLA headlights, carpet projectors,...
- Micro camera lenses for photography, AR, life sciences...
- Lighting structures

Application requirements for masters:

- Mass production by UV Imprint replication (WLO, R2R, R2P) & ICM
- Very tight specifications on asphere & freeform shapes, roughness, form accuracy, uniform quality, ...
- High sags, high slopes, 100% fill factor
- Up to Fully populated 8" masters (optimized use of replication area)









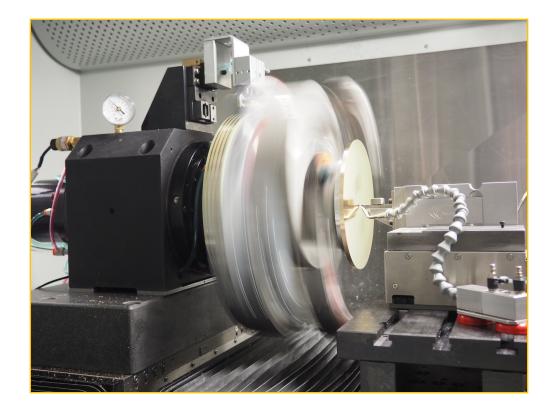
DPI® TECHNOLOGY

Dynamic Part Indexing (DPI®) is:

- A patented technology 100% developed and owned by Wielandts UPMT
- Dynamically offset the part wrt the work-spindle in a balanced manner using eccentric rotary movements
- Sequentially 2/3-axis Single Point Diamond Turning of each lens on the workspindle axis
 - → best, repeatable form and roughness
 - Rougness: 2 nm (NiP)
 - Form irregularity: 100 nm p-v
- Up to 8" masters with highest position accuracy:
 - Lens to lens: < 1 μ m,
 - MLA to MLA: < 1 μ m

Optical design freedom:

- Aspheres, mild freeforms, diffractive structures ...
 - Feature size: > 10 µm
 - Lens sag: < 10 mm
 - Edge slopes: < 80° (limited by tool clearance)
 - 100 % fill factor
 - Each lens can have a different optical definition !
- Alignment fuducials, reference surfaces, ...



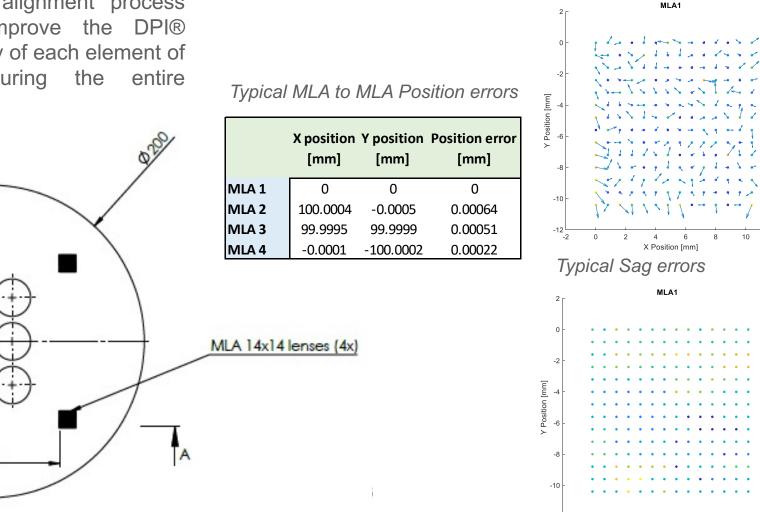


CLAP™ SUBMICRON ALIGNMENT

CLAP[™] is an alignment process designed to improve the DPI® position accuracy of each element of the master during the entire process.

100

8



Typical XY Position errors

Proprietary and Confidential !

-2

4 6

X Position [mm]

Hist - MLA1

40

30

20

60

40

20

12 × 10⁻¹

10

0

2

4

Hist - MLA1

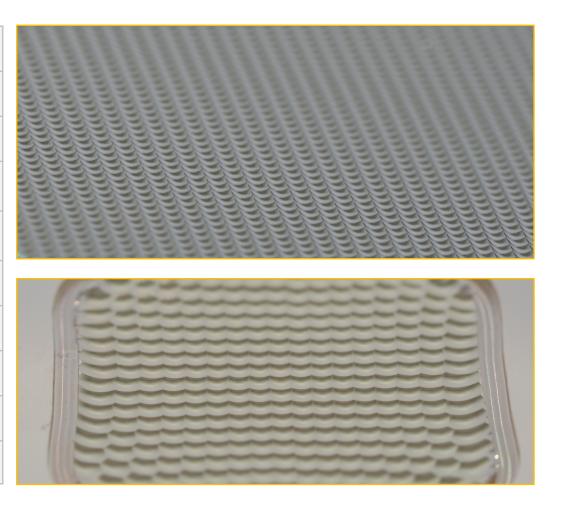
Sag error [mm]

Pos error [mm]

**

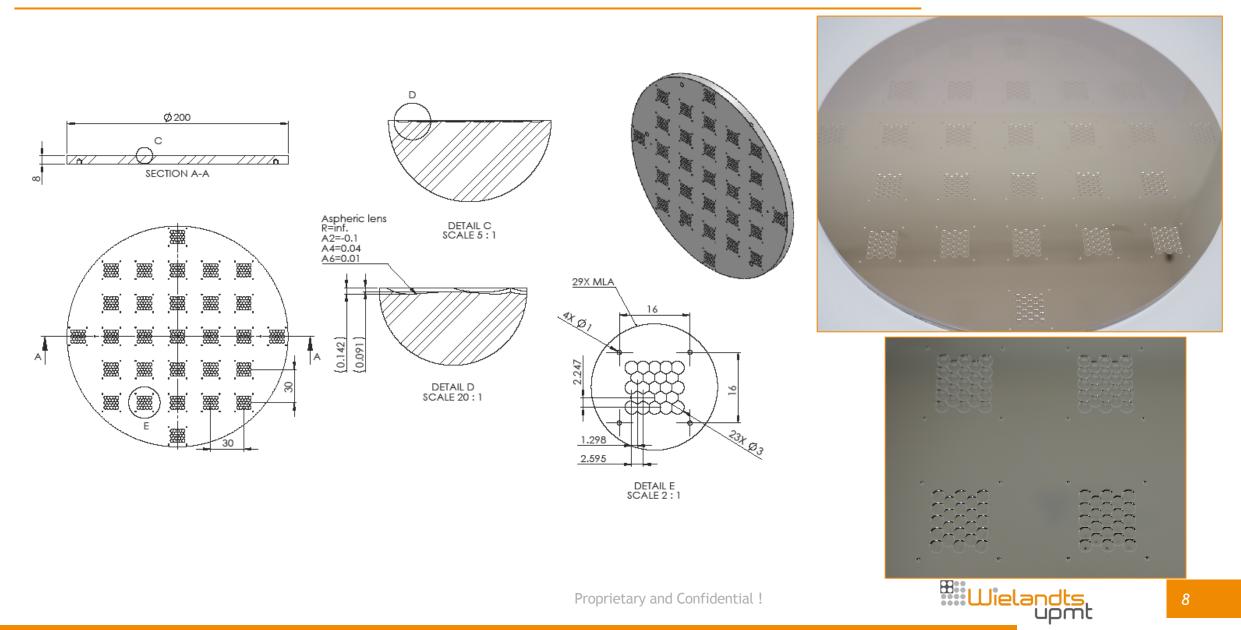
EXAMPLES OF DPI® MASTER STRUCTURES

Substrate material	NiP	NiP
Shapes	Aspheres	Freeform, all lenses different
Feature sizes	0.7 mm	3mm
Lens sag	200 µm	500 µm
Form irregularity	200 nm p-v	300 nm p-v
Ra roughness	3 nm	3 nm
Edge slopes	50°	25°
100% fill factor	Yes	Yes
Position accuarcy	Lens to lens: < 1 µm	Lens to lens: < 1 µm
Number of lenses	> 10.000	300





EXAMPLE OF A FULLY POPULATED DPI® MASTER



TECHNOLOGY STATUS & COLLABORATION ITEMS

DPI[®] status :

- V2: industrialised
- with CLAP[™] : now validated for 8 inch
- Ready for your applications !

Ongoing development – collaborations wished:

- Strong freeforms & non machinable surfaces
- Inverting to 100% fill factor convex structures
- Cleaning
- Coating
- Dicing

We thank You for your attention & are looking to collaborate !









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New address !

WIELANDTS UPMT sa 36, Rue Louis Plescia 4102 Seraing, Belgium +32 4 378 03 20 info@upmt.be www.upmt.be

marc.wielandts@upmt.be +32 499 37 65 33